



031,68095

PATENT APPLICATION 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshaiahu Fainman
Serial No.: 10/521,425
Conf. No.: 9057
Filed: 3/22/2005
For: HOLOGRAPHICALLY DEFINED SURFACE
MASK ETCHING METHOD AND ETCHED OPTICAL
STRUCTURES
Art Unit: 2814
Examiner: Rao, Shrinivas H.

)
) I hereby certify that this paper is being deposited with
) the United States Postal Service as FIRST-CLASS mail
) in an envelope addressed to: Commissioner for Patents,
) P.O. Box 1450, Alexandria, VA 22313-1450, on this
) date.
) 8/7/07
) Date Registration No. 43,874
) F-CLASS.WCM Attorney for Applicant(s)
) Appr. February 20, 1998
)
)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL

Dear Sir:

Transmitted herewith is a communication regarding the above-identified application.

Fee Calculation For Claims As Amended

	As Amended		Previously Paid For		Present Extra		Rate		Additional Fee
Total Claims	21	-	21	=	0	x	\$ 50.00	=	\$ 0
Independent Claims	3	-	3	=	0	x	\$200.00	=	\$ 0
Fee for Multiple Dependent Claims							\$360.00	=	\$ 0
							Total Additional Fee		\$ 0
							Small Entity Fee (reduced by half)		\$

- (X) Amendment A.
- (X) Supplemental Information Disclosure Statement with \$180 check; Form PTO 1449;
Cited documents.
- (X) If a Petition under 37 C.F.R. §1.136(a) for an extension of time for response is required to make the attached response timely and does not separately accompany this transmittal, Applicant(s) hereby petition(s) under 37 C.F.R. §1.136(a) for an extension of time for response in the above-identified application for the period required to make the attached response timely.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

August 7, 2007
300 South Wacker Drive – Suite 2500
Chicago, Illinois 60606
Tel.: (312) 360-0080
Fax: (312) 360-9315
Customer No.: 24978

Respectfully submitted,

GREER, BURNS & CRAIN, LTD.
By: Arik B. Ranson
Arik B. Ranson, Reg. No. 43,874



0321.68095

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SURFACE MASK ETCHING
METHOD AND ETCHED OPTICAL
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8/17/07 Al F. R
Date Registration No. 43,874
F-CLASS.WCM
Appr. February 20, 1998 Attorney for
Applicant(s)

AMENDMENT A

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed May 7, 2007.